



37505.0313 *HW*

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Rosemarie Contella

Name

Rosemarie Contella

Signature

February 11, 2005

Date of Signature

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : Palazzo et al.
Serial No. : 10/763,945
Filed : January 22, 2004
For : Electrochemical Treatment
Method To Reduce Voltage
Delay And Cell Resistance In
Lithium/Silver Vanadium Oxide
Cells

Examiner : Unknown
Art Unit : 1745

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT
PURSUANT TO 37 CFR 1.56**

Assistant Commissioner for Patents
Alexandria, VA 22313-1450

1. Applicants submit herewith patents, publications or other information of which they are aware, which they believe may be material to the examination of this application and in respect of which there may be a duty to disclose in accordance with 37 CFR 1.56.

The filing of this Information Disclosure Statement (IDS) shall not be construed as a representation that a search has

been made (37 CFR 1.56(g)), an admission that the information cited is, or is considered to be, material to patentability or that no other material information exists.

The filing of this IDS shall not be construed as an admission against interest in any manner (Notice of Jan. 9, 1992, 1135 O.G. 13-25, at 25).

2. Attached is Form PTO-1449.

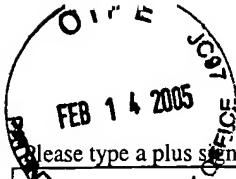
3. No item of information contained in this IDS was cited in a communication from a foreign patent office in a counterpart foreign application, or to the knowledge of the person signing the certification after making reasonable inquiry, was known to any individual designated in § 1.56(c) more than three months prior to the filing of the statement.

4. The person making this statement is the agent who signs below, who makes this statement on the information supplied by the inventors and the information in the agent's file.

Respectfully submitted,

By 
Michael F. Scalise
Reg. No. 34,920

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February 11, 2005



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PTO/SB/08A(08/00)

Approved for use through 10/31/2002, OMB 0651-0031

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**
(Use as many sheets as necessary)

Sheet 3 of 3

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U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

Examiner Signature		Date Considered	
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***EXAMINER:** Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Unique citation designation number. 2 See attached Kinds of U.S. Patent Documents. 3 Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). 4 For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. 5 Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. 6 Applicant is to place a check mark here if English language Translation is attached.